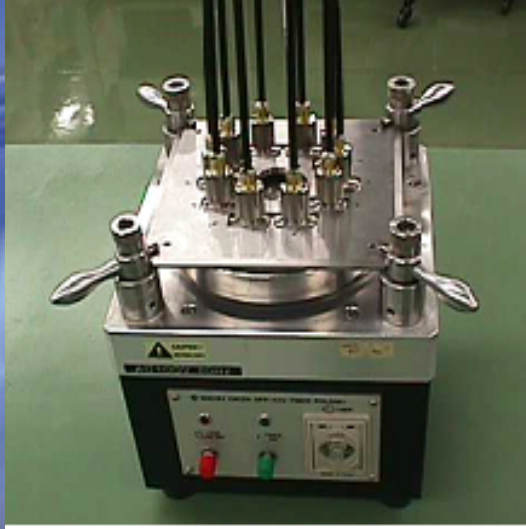




SEIKOH GIKEN



OptiTap Polishing Machine

Mass Production OptiTap Solution

Polishing Machine : SFP-550

Polishing Holder : PH55-OPT8C-10

■ Features

- OptiTap Mass Polishing Machine
High performance · High yield · Cost reduction
- Provide polishing result easily satisfies IEC standard

POLISHING PROCESS	POLISHING CONDITION			
	PAD	FILM (life)	POLISHING LIQUID	TIME (Min.)
ADHESIVE REMOVAL	PS5X-500-00	GA5D (5)	NONE	0.5
FIRST POLISHING	PG5X-490-00	DA5D (10)	PURIFIED WATER	1.5
SECOND POLISHING	PR5X-500-90	DH5D-3U (15)	PURIFIED WATER	1.0
FINAL POLISHING	PR5X-500-90	XF5D (5)	PURIFIED WATER	0.5

Polishing process is varied by pedestal diameter. The above condition is based on ferrule with pedestal diameter D0.60mm and chamfer angle 45-degree.

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Seikoh Giken reserves the right to improve, enhance and modify features and specifications of Seikoh Giken products without prior notifications